

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	36	(205/640.ccls. 216/38.ccls.) and ((surface RMS (root near mean near (square squared))) adj roughness)	US-PGPUB	OR	ON	2008/06/10 11:13
L2	100	((surface RMS (root near mean near (square squared))) adj roughness) same (electropolish electropolish\$3)	US-PGPUB	OR	ON	2008/06/10 11:14
L3	36	((surface RMS (root near mean near (square squared))) adj roughness) same (electropolish electropolish\$3)	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/10 11:15
S1	21	("2330562" "20030036483" "20030144150" "20050000826" "4372831" "5066370" "5843290" "6228246").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/04 11:09
S2	1	(mirror near gloss near finish) same (roughness)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/13 15:08
S3	4	(mirror near gloss near (finish surface)) same (roughness)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/13 17:36
S4	4	(mirror near gloss near (finish surface)) same (roughness RMS)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/07/20 20:24

S5	3162	(mirror near2 (finish surface gloss)) same (roughness RMS)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/13 17:37
S6	145	(mirror near2 (finish surface gloss)) same (roughness and RMS)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/13 17:37
S7	2	"20050016867".pn.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/07/20 20:23
S8	1445	C25F003/00.ipc.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/07/20 20:24
S9	0	S8 and (roughness near2 RMS with (nm nanometer))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/07/20 20:25
S10	8	S8 and (roughness with (nm nanometer))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/07/20 20:27
S11	2	205/640.ccls. and (roughness with (nm nanometer))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/07/20 20:27
S12	2	205/640.ccls. and (roughness with (nm nanometer angstrom))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/07/20 20:27

S13	9	S8 and (roughness with (nm nanometer angstrom))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/07/20 20:31
S14	21	216/38.ccls. and (roughness with (nm nanometer angstrom))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/07/20 20:31
S15	27	205/640-686.ccls. and ((high high\$3 large) near current) with (smooth smooth\$3 rough roughness)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/04 12:25
S16	10	205/640-686.ccls. and ((high high\$3 large) near current) with (smooth smooth\$3 rough roughness) and (electropolish electropolish\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/04 12:28
S17	53	205/640-686.ccls. and ((high high\$3 large great greater) near2 current) same (smooth smooth\$3 rough roughness) and (electropolish electropolish\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/04 12:28
S18	1	205/640-686.ccls. and (current) same (smooth smooth\$3 rough roughness) with ("1 nm" "1nm") and (electropolish electropolish\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/09 15:58
S19	1	("204" "205").clas. and (current) same (smooth smooth\$3 rough roughness) with ("1 nm" "1nm") and (electropolish electropolish\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/09 15:58

S20	5	("204" "205").clas. and (smooth smooth \$3 rough roughness) with ("1 nm" "1nm") and (electropolish electropolish\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/09 15:59
S21	22	("204" "205").clas. and (smooth smooth \$3 rough roughness) with (nm) and (electropolish electropolish\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/09 16:01
S22	11	("204" "205").clas. and (surface adj roughness) with (nm) and (electropolish electropolish\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/09 17:44
S23	16	("204" "205").clas. and ((surface RMS (root near mean near (square squared))) adj roughness) with (nm nanometer) and (electropolish electropolish\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/09 17:46
S24	21	((surface RMS (root near mean near (square squared))) adj roughness) with (nm nanometer) same (electropolish electropolish\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/09 17:49
S25	80	((surface RMS (root near mean near (square squared))) adj roughness) with (nm nanometer) and (electropolish electropolish\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/09 17:57
S26	80	((surface RMS (root near mean near (square squared))) adj roughness) with (nm nanometer "1nm" "2nm") and (electropolish electropolish\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/09 18:08

S27	255	((surface RMS (root near mean near (square squared))) adj roughness) same (electropolish electropolish\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/09 18:09
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6/10/2008 11:17:24 AM

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